



Cite this: *J. Mater. Chem. C*, 2022,
10, 16714

Exploring the optoelectronic properties of SnSe: a new insight†

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Tin selenide has established its sound presence among 2D materials. A recent trend in the thermoelectric application study of this material has led to ignoring its optoelectronic potential. Here, we are unraveling its optoelectronics (viz., photodetector and solar cell) potential. Oxidation of the chalcogenides seems to be a boon for tin selenide for its optoelectronic properties. Tin selenide annealed at 300 °C in the open air for different times (0.5, 1, and 1.5 h) shows three consecutive layers (viz. SnSe, SnSe₂, and SnO₂). After the open-air annealing of SnSe, an enhanced photo-response in the broad spectrum is observed. A spectral response in the broad range of 250–1250 nm is observed compared to unannealed SnSe. Annealing time can tune the response in the required region, such as the ultraviolet and near-infrared regions. A maximum of 0.125 mA W^{−1} responsivity in the ultraviolet region (355 nm) for 1.5 h annealed and ~0.117 mA W^{−1} for 0.5 h annealed in the near-infrared region has been observed. The layers formed are naturally in the form of basic solar cell structures. Experimentally the solar cell efficiency obtained after annealing indicates a new area of exploration for SnSe. A solar cell simulation study (by the simulation program SCAPS-1D) showed that efficiency is very sensitive to the electron affinity of the SnSe₂ layer and could reach up to 20.28% under some defined conditions. This fabrication technique for the solar cell can substitute a clean room facility for the fabrication. The open-air annealing led to a better device in terms of responsivity, stability against environmental conditions, and natural formation of the solar cell. Also, this is the first ever reported device that can be uniquely formed just by open-air annealing. Optimizations in the parameters may open a new door in the fabrication technology of solar cells.

Received 9th September 2022,
Accepted 27th October 2022

DOI: 10.1039/d2tc03799h

rsc.li/materials-c

Introduction

Opto-electronics is the core of material sciences in terms of its application like optical communication, robotics, wearable electronics, bio-imaging, *etc.*^{1–3} Conversion of the optical signal (photons) into the electrical output on a broader spectral range enhances its demand in video imaging, biomonitoring, *etc.*^{3–5} A photodetector should have a high responsivity, detectivity (high signal-to-noise ratio), fast response, and broad spectral response. Commercialized broadband photodetectors face low

detectivity (like Si) and high costs of fabrication (like Si and GaN-based).^{5,6}

Tin selenide is one of the recently researched chalcogenide materials. Its multifunctional applications have recently attracted much attention^{7–12} and it has been highly researched for its thermoelectric properties.^{13–16} There are very few reports in the literature that focus on the photoconductive^{17–25} and photovoltaic^{26–30} properties of tin selenide due to the one-sided focus on thermoelectrics. Tin chalcogenides are highly sensitive to surface oxidation, even at room temperature.³¹ The response time and responsivity for SnSe vary from a few microseconds to a few tens of seconds and a few milli to thousands of A W^{−1}, respectively.^{17,32} But these reports focus on the visible NIR region, for pure SnSe film, with heterostructures, nanowires, quantum dots, *etc.*^{18,32–35} A few reports emphasized the effect of annealing in an inert atmosphere in terms of improved crystallinity,^{36,37} but still, a comparison is missing. Gupta *et al.* recently reported the effect of annealing in an inert atmosphere on the photoconductive properties of SnSe₂, which led to overall improved film performance when annealed at 150 °C.³⁸ Inert atmosphere post-annealing or *in situ*

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† Electronic supplementary information (ESI) available. See DOI: <https://doi.org/10.1039/d2tc03799h>

annealing led to better crystallinity,³⁶ reduced defect states,³⁹ and enhanced absorption.²⁹ Introducing defects in a controlled manner in SnSe related to Se vacancy or loss also improved the photoconductive performance of the SnSe in terms of response speed, responsivity, and covered spectral range.⁴⁰

Oxidation of metal chalcogenides is considered to deteriorate their properties. Many strategies have been applied to protect the material from harmful environmental conditions, like protective layers coating,³¹ surface engineering, *etc.* Pataniya *et al.* showed the behavior of photodetection performance of SnSe quantum dots under vacuum and environmental conditions. Adsorbed oxygen effectively increased the dark current in the device by lowering the Fermi level but added oxygen defect states which enhanced the photocurrent *via* photogain due to the long-lived trapping of excited carriers. Photoresponsivity increased but at the cost of response time under environmental conditions other than a vacuum.³²

A detailed study of the chemical and thermal stability was analyzed in our previous study.⁴¹ The current work studies the effect of annealing SnSe in the open air at 300 °C for different times (*viz.* 0.5, 1, and 1.5 hour). It led to the formation of three consecutive layers, *viz.*, SnSe, SnSe₂, and SnO₂. It shows that annealing benefits the photoconductive properties and extends the spectral range covering the ultraviolet, visible, and near-infrared (UV-Vis-NIR) regions. Here oxidation of SnSe seems to be a boon for its optoelectronic applications, while it appears to be a bane for thermoelectric applications.⁴²

In this work, the first section compares the spectral response of the unannealed and annealed SnSe, showing the annealing time's effect on the photoconductive performance. After annealing, the responsivity and detectivity of the devices improved with the additional benefits of improved stability against environmental conditions. Devices (1.5, 1, and 0.5 h annealed) showed maximum responsivity values of 0.125 mA W⁻¹ under 355 nm, 0.095 mA W⁻¹ under 1064 nm, and 0.117 mA W⁻¹ under 1064 nm, respectively. Also, we are reporting the inherent nature of SnSe as a solar cell device because all the required structures, like the p-type absorber layer, n-type buffer layer, electron transport, and window layer, formed upon annealing. After the open-air annealing with controlled conditions, p-type SnSe, n-type SnSe₂, and SnO₂ as window layers formed.

Solar cell based on SnSe and Si had a maximum efficiency of around ~6.44%⁴³ and SnSe has the potential to reach up to 27.7%.⁴⁴ Theoretical and experimental demonstration of the as-obtained solar cell device is presented. The simulation program SCAPS-1D was used for the theoretical investigation of the performance of the natural device. The experimental study was carried out by depositing SnSe thin film by thermal evaporation followed by open-air annealing at 300 °C for different times (*viz.* 0.5, 1, and 1.5 hours). Overall, such a technique opens a new door for solar cell fabrication, which doesn't require any clean room facilities for solar module fabrication, proving to be very cost effective.

We are reporting the hidden efficacy of SnSe in photoconductive (PC) and photovoltaic (PV) devices in addition to its good performance in the thermoelectric field. This report is

subdivided into two sections, with the PC and PV performance in the first and second sections, respectively.

Experimental details

A detailed description of the deposition of the film using the thermal evaporation method is given in ref. 41. The film is cut into 5 × 10 mm² pieces and placed in a furnace at a temperature of 300 °C for one hour with a 2 °C min⁻¹ ramp rate followed by natural cooling. Raman spectroscopy (Jobin-Yvon T 6400 triple monochromator, excitation wavelength provided by ionized argon 785 nm) was used to confirm the phases in the film in the range 50–400 cm⁻¹.

For PC mode

A probe setup station (S10 Triax probe station with Keithley 2450 source meter acquisition unit with an accuracy of 10 nA in current readings and 100 μs in response time assessment) was used to perform wavelength correlated bias and power-dependent photoresponse measurements. The system includes a laser source with varying power densities (355 nm, 532 nm, and 1064 nm). The spectral responses of the devices are measured in the darkroom using a 450 W Xenon Lamp. The effective area of the device for the PC measurements is taken as 0.04 mm².

For PV mode

Current, voltage is measured using the Keithley 4200 semiconductor characterization system. A solar simulator AM 1.5G (class AAA, Photo Emission Tech.) was used for illumination purposes.

Device structure

The device structure can be explored after the open-air annealing at 300 °C for a given time. This type of solar cell structure can also be made by simply transferring the SnSe₂ and SnO₂ layers onto the SnSe (by taking the buffer layer as SnSe₂ and the window layer as SnO₂). Fig. 1 shows the transformation of SnSe into three consecutive layers after annealing, where the upper- and lower-sections show the PC and PV devices, respectively. With the annealing under defined conditions, the thickness of the SnSe layer decreases due to the thermal and chemical instability of SnSe under defined conditions.⁴¹

Results and discussions

Annealing in an inert atmosphere led to improved phases in terms of crystallinity and defects,^{36,37,45} but under open air led to changes and sometimes rearrangements of the phases in the material.⁴¹

Phase evolution of the SnSe film on glass is studied using Raman spectroscopy when kept under an annealing condition of 300 °C for different times; the results are shown in Fig. 2(a) and (b). Raman is a bulk and surface-sensitive characterization

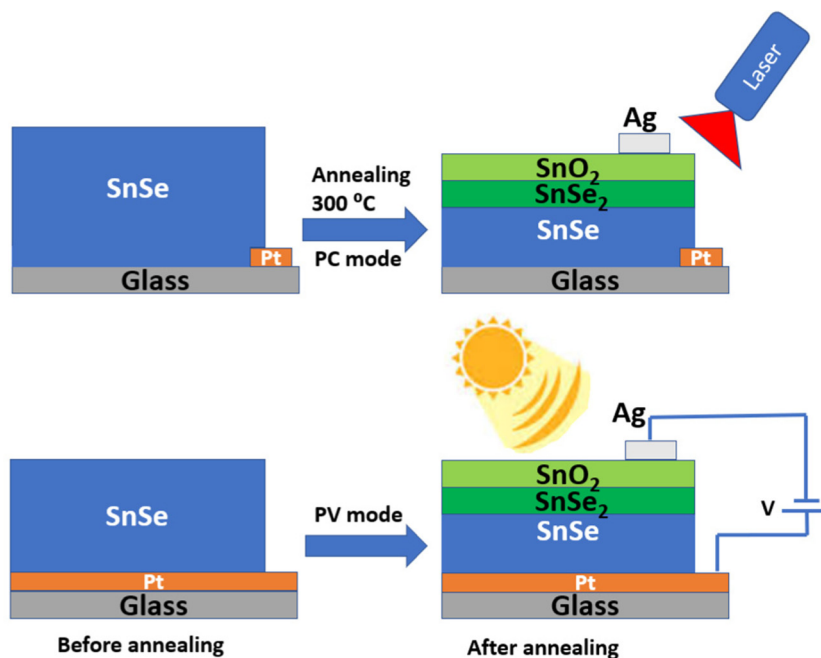


Fig. 1 Upper and lower sections: device structures implemented by open-air annealing for PC and PV, respectively, of SnSe at 300 °C for a defined time.

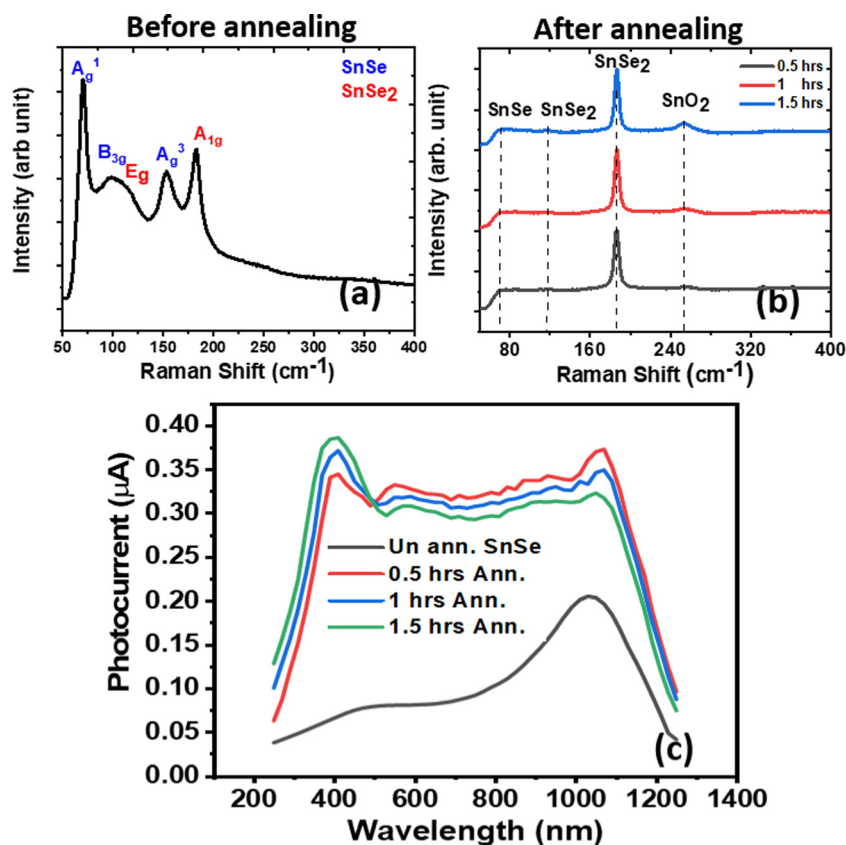


Fig. 2 Raman spectra of SnSe (a) before and (b) after annealing, and (c) spectral response of the un-annealed and different time annealed SnSe at 300 °C.

technique due to its depth probing in bulk and sensitivity towards trace phases on the surface. The first three peaks of the Raman spectrum before annealing (Fig. 2(a)) match well with the previous report²⁴ and show some sign of SnSe₂²⁵

(labeled red in the figure) in the SnSe that may be due to the oxide formation at room temperature.^{31,46} In contrast, the SnO/SnO₂ peak was not significant at room temperature, possibly due to the amorphous nature of the SnO/SnO₂. Peak height and resolution can vary in the Raman spectrum due to using different excitation wavelengths in power laser irradiation, which may cause the lower peak intensity at 130 cm⁻¹ corresponding to the A_g² mode in unannealed SnSe.⁴⁷

After annealing (Fig. 2(b)), a broad peak appears at ~252 cm⁻¹, corresponding to SnO₂, which matches well with the literature.⁴⁸ Also, it can be easily inferred that with increasing annealing time, the SnO₂ peak height increases, which shows the increased and improved crystallinity of SnO₂ due to elongated exposure to oxygen. As the peak corresponding to SnSe is significant at room temperature and only peaks of SnSe₂ and SnO₂ become intense at different stages of annealing, this implies that the SnSe phase is not present in the upper layers. Tin is more prone to oxide formation when heated and forms an oxide called SnO₂.³¹ After the formation of oxides, plenty of Se atoms in SnSe remain ready to patch up the gaps. Due to the imbalance of the stoichiometric ratio of 1:1 of Sn and Se, rearrangements of Se atoms happen, and SnSe₂ is formed.^{31,46} A detailed mechanism of the appearance of these layers after annealing is discussed in our previous report.⁴¹ Raman spectroscopy was performed at randomly chosen spots on the sample to test the homogeneity of the structures in the device, and the

results are shown in Fig. S1 (ESI†). From these spectra, one can conclude that the distribution of layers is homogeneous throughout the device.

Section 1. PC performance of the device

In our previous report, we have seen that different annealing temperature leads to an enhanced photoconductive (PC) performance of the SnSe, and annealing at 300 °C leads to broad-band photoconduction.⁴¹ *I*-*V* characteristics of the devices are shown in Fig. S2 (ESI†). Here different annealing time at 300 °C is studied, which shows that with the increase in the annealing time, an increment in the PC performance in the UV region is followed by a decrement in the PC performance in the NIR region. The spectral responses of the devices and their comparison with the unannealed SnSe are shown in Fig. 2(c). With the increasing annealing time, the crystallinity and thickness of the SnO₂ layer increased, as confirmed by the Raman spectrum (Fig. 2(b)). So, UV response increases. Also, as the thickness of SnO₂ increases, it is at the cost of a decrease in SnSe thickness because long exposure of Sn to oxygen leads to more SnO₂ (from the surface to the depths of the film), and after the rearrangement of the Se atoms, the SnSe thickness decreases.

The device's cyclic stability at different wavelengths (355, 532, and 1064 nm) was studied. PC measurements at 500 mV at 15 mW cm⁻² power density are shown in Fig. 3(a)–(c). The very

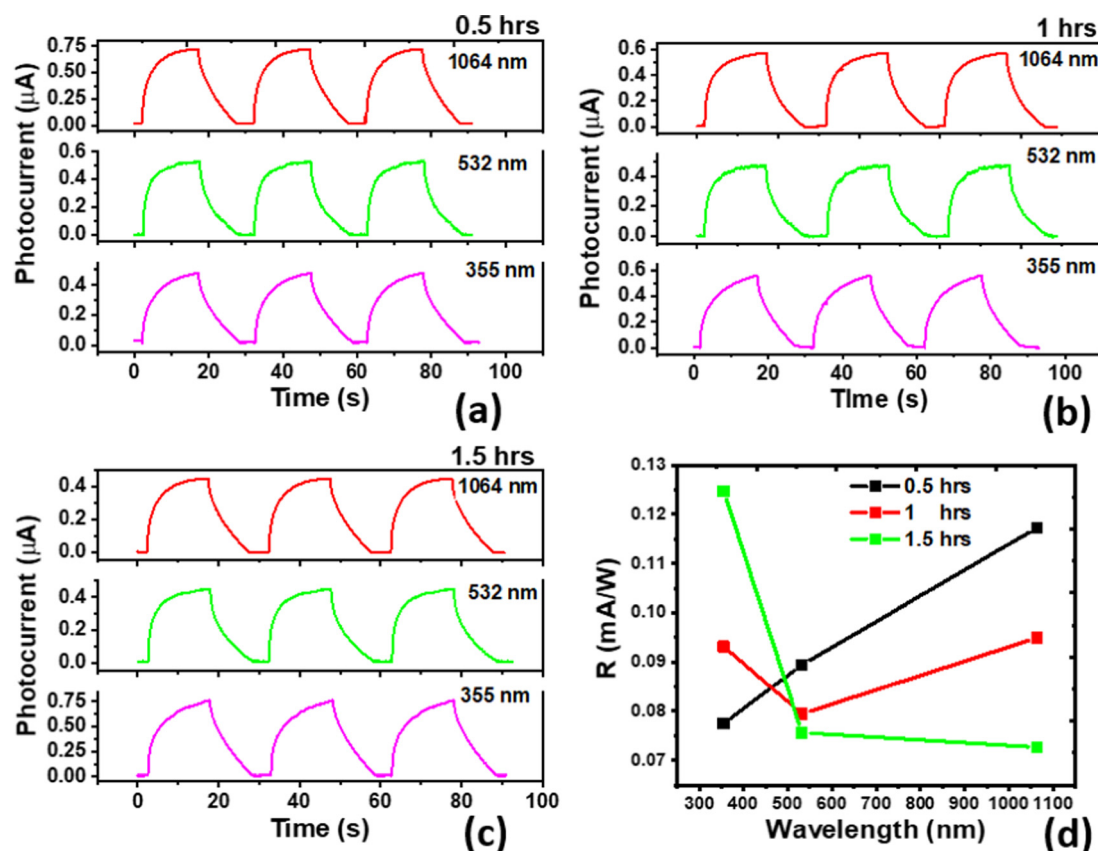


Fig. 3 Cyclic stability (a)–(c) and responsivity (d) of the devices annealed at 300 °C for 0.5, 1, and 1.5 h, respectively, under 355, 532, and 1064 nm.

high stability of the PC performance over the entire selected spectra showed its suitability for the optoelectronic field.

The responsivities of the devices are shown in Fig. 3(d). Compared to our previous results of PC measurements on SnSe thin film,¹⁴ responsivity may be low due to the large effective area (~ 20 times larger area) and different power densities used for these devices. Responsivity is sensitive to the effective area of the device and inversely proportional to the device's irradiated power density and effective area. Their relationship is given by $R = \frac{I_{ph}}{P \cdot A}$, where I_{ph} , P , and A are the photocurrent, irradiated power density, and effective area of the device, respectively. A small area leads to a lower number of photons illuminated. Still, due to the trap/defect states in the device, it becomes important to minimize the spacing between electrodes for improved responsivity.

Also, the previous report²² on annealed samples at 300 °C showed nearly the same order for the photocurrent in the visible region, but for UV and IR, the current is enhanced by two orders. This discrepancy may be due to different effective areas, the contacts' positions and nature, and the laser light's power density. The maximum detectivity of the device at 1.5 h annealed is 4.3×10^{10} Jones, the maximum among all the devices at 355 nm. Variation of the detectivity with the wavelength and the annealed time is shown in Fig. S3 (ESI†).

The rise and decay time fittings of the photocurrent at 1064 nm for 0.5, 1, and 1.5 h annealed devices are shown in Fig. S4 (ESI†). Response and recovery times of the 0.5, 1, and 1.5 h annealed devices are 4.80/8.19, 4.37/7.07, and 4.82/8.20 s, respectively, for 1064 nm illumination. In terms of rise time, all devices showed nearly the same time, while the recovery time showed that the 1 h annealed device has fewer defect/trap states than the others (0.5 and 1.5 h annealed). Thus, annealing for more than 1 h also led to increased defect states in the device, and 1 h of annealing seems to be an optimized time. It is observed that response time is greatly affected by the annealing, which may be due to the traps/defects arising in the device after annealing or, say, traps/defects dominated the photocurrent as compared to the original device in our previous work.²⁴ Also a long exponential tail in the decay time confirms the supposition of the domination of trap/defect states in the device.^{49–51}

Section 2. PV performance of the device

Experimental. Generally, solar cell fabrication involves many deposition steps of layers like absorber, buffer, window layer, etc., and requires a high-class clean room facility. A complete solar cell just by the open-air annealing of SnSe thin film under defined conditions is reported for the first time.

The present experimental solar cell efficiency is indicative of the idea's potential. The efficiencies of 0.05, 0.11, and 0.25% were obtained for the samples annealed for 0.5, 1, and 1.5 h, respectively. I - V characteristics of the devices under AM 1.5G solar radiation are shown in Fig. 4. A photograph of the solar cell device (film annealed for 1 h) is shown in Fig. S5 (ESI†). A detailed explanation of the cell efficiency is provided in the last

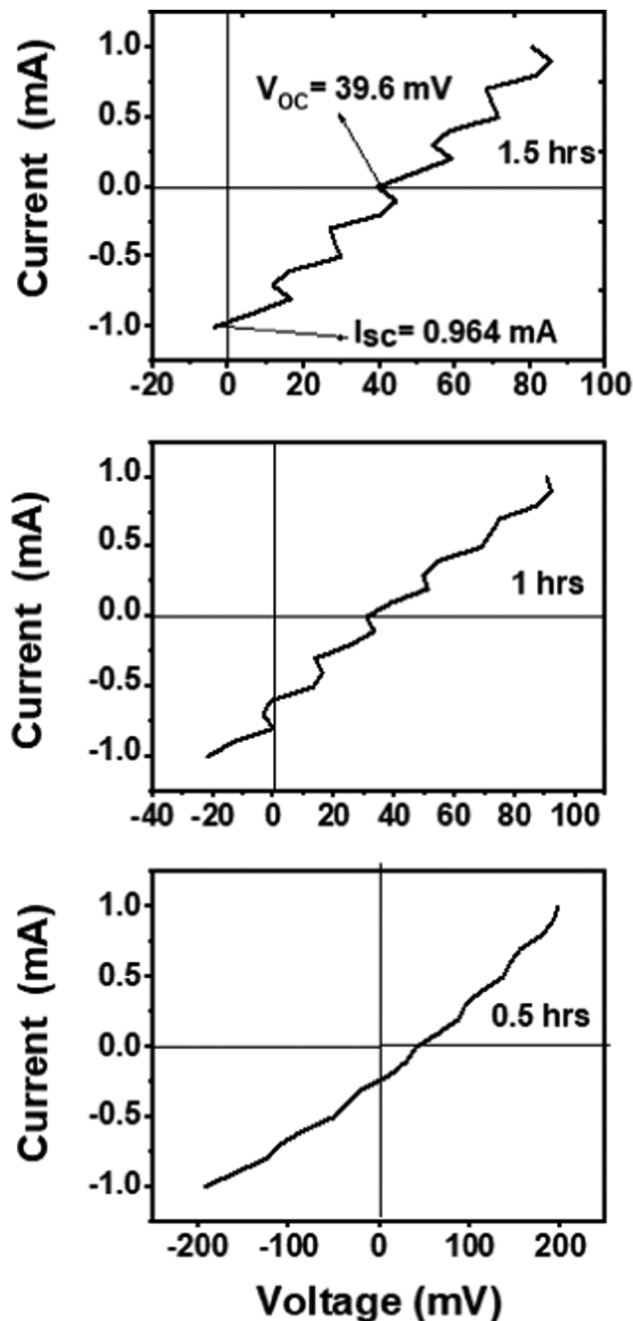


Fig. 4 I - V characteristics of the solar cell devices under AM 1.5G optical power.

part, along with the theoretical simulation results of the same solar cell structure. After annealing, the theoretical efficiency of the as-obtained system can reach up to $\sim 20\%$.

Theoretical work

Simulation methodology

The performance of the SnSe/SnSe₂/SnO₂ cell is evaluated with the help of the SCAPS-1D software. Detailed studies about the

program, algorithm, and equations for the electron and hole can be found in ref. 52–54.

Results and discussion

The absorber layer is the most focused part of the solar cell. Many strategies are employed to enhance the efficiency of the solar cell after selecting the appropriate buffer layer. Buffer layer selection must guarantee the formation of the p–n junction. In the solar cell structure of SnSe/SnSe₂/SnO₂, the buffer layer (SnSe₂) plays a vital role. The electron affinity of SnSe₂ plays an important role in the efficiency of this solar cell. Generally, SnSe₂ shows a very high work function 5.0 ± 0.1 eV.^{55,56} Roy *et al.*⁵⁷ have reported 4.6 eV as the work function of SnSe₂. D'Olimpio *et al.*⁵⁸ reported that this discrepancy in the work function values is due to the surface oxidation of SnSe₂ at room temperature, which leads to the formation of SnO₂. Here we have varied the electron affinity of the SnSe₂, which is very sensitive to surface oxidation, from 4.4 to 5.0 eV in steps of 0.2 eV as shown in Fig. 5(a) and (b) at valence band effective density of states (N_V), conduction band effective density of states (N_C), radiative recombination coefficient (RRC), electron and hole mobility of $1.8 \times 10^{19} \text{ cm}^{-3}$, $2.2 \times 10^{18} \text{ cm}^{-3}$, 1×10^{-6} , $36.65 \text{ cm}^2 \text{ s}^{-1} \text{ V}^{-1}$ and $3.74 \text{ cm}^2 \text{ s}^{-1} \text{ V}^{-1}$, respectively.

With the increased electron affinity of the SnSe₂, the efficiency of the cell decreased due to an increased notch in the band alignment of SnSe and SnSe₂ that impedes the carrier collection.⁵⁹ Efficiency increases from $\sim 1\%$ to 7% when the electron affinity of SnSe₂ decreases from 5.0 to 4.4 eV. Band alignment is shown in Fig. 6, where the electron affinity (E.A.) of SnSe₂ is taken as 4.4 eV (Fig. 6(a)) and 5.0 eV (Fig. 6(b)). This schematic shows how this variation of the E.A. of SnSe₂ impedes carrier transportation. For the increasing E.A. of the SnSe₂, the height of the potential barrier between the SnSe and SnSe₂ interface increases, and also formation of a potential well in the SnSe₂ layer can be seen in Fig. 6. The sandwiched SnSe₂ layer behaves like a potential well for the carriers. Hence the transportation of carriers is largely affected and hence the lower efficiency.

Also, by controlling the open-air annealing conditions, the thickness of the SnSe₂ and SnO₂ can be varied. With the increase in the annealing time or temperature, oxidation and

hence the thickness of the SnSe₂ and SnO₂ can be varied. The long-time annealing may lead to the formation of a homogeneous oxide layer. After the oxidation of SnSe and the formation of SnO₂, an imbalance in the stoichiometry ratio of Sn and Se atoms is created. Rearrangements of the Sn and Se atoms occur, leading to the formation of SnSe₂ due to Sn deficiency.^{31,46} To study the device's sensitivity toward the thickness of the SnSe₂/SnO₂, we varied the thickness of these layers in the 25–100 nm range in steps of 25 nm, as shown in Fig. S6(a) and (b) (ESI†). Although the thickness of layers plays a vital role in the device in terms of homogeneity of the layers, cell efficiency seems insensitive to the thickness of the buffer and window layers. After optimizing the buffer and window layer parameters, when the absorber layer is optimized with selected parameters (N_V , N_C , RRC, electron and hole mobility of $2.2 \times 10^{15} \text{ cm}^{-3}$, $1.8 \times 10^{16} \text{ cm}^{-3}$, 1×10^{-6} , $1000 \text{ cm}^2 \text{ s}^{-1} \text{ V}^{-1}$ and $100 \text{ cm}^2 \text{ s}^{-1} \text{ V}^{-1}$, respectively) given in the previous report⁴⁴ (with 50 nm thickness for the SnSe₂ and SnO₂ layers), the efficiency of the cell reaches up to 20.28% (Fig. S7, ESI†).

At last, the solar cell based on SnSe/SnSe₂/SnO₂ can also be exploited with open-air annealing, where annealing conditions require more focused research so that a homogeneous layer of SnSe₂ and SnO₂ can be optimized. The electron affinity of the SnSe₂ controls the device's overall performance and is also sensitive to oxidation, as inferred from the above section. Still, many defects/traps exist in the devices that impede their efficiency, as verified by the response time. More research must be done to optimize the annealing conditions (like annealing in a pure oxygen atmosphere for forming SnO₂ or annealing under an inert atmosphere for better rearrangement of the atoms in the layers after open-air/controlled oxygen atmosphere annealing that could improve the E.A. of SnSe₂) so that the electron affinity of SnSe₂ can be tuned. Such a strategy will not only lead to a stable and self-powered photodetector but also the fabrication of the solar cell will lead to a stable and cheap device.

Conclusion

Tin selenide has immense potential as an optoelectronic material. Open-air annealing not only derived its hidden capacity in the PC mode but also in the PV mode. Robust, broadband PC

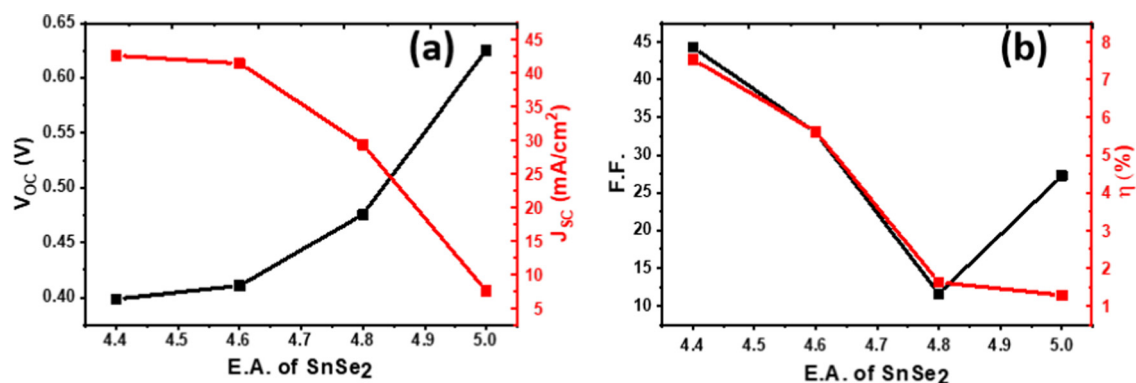


Fig. 5 Effect of electron affinity on the parameters V_{OC} , J_{sc} (a), FF, and efficiency (η) (b) of the SnSe-based solar device.

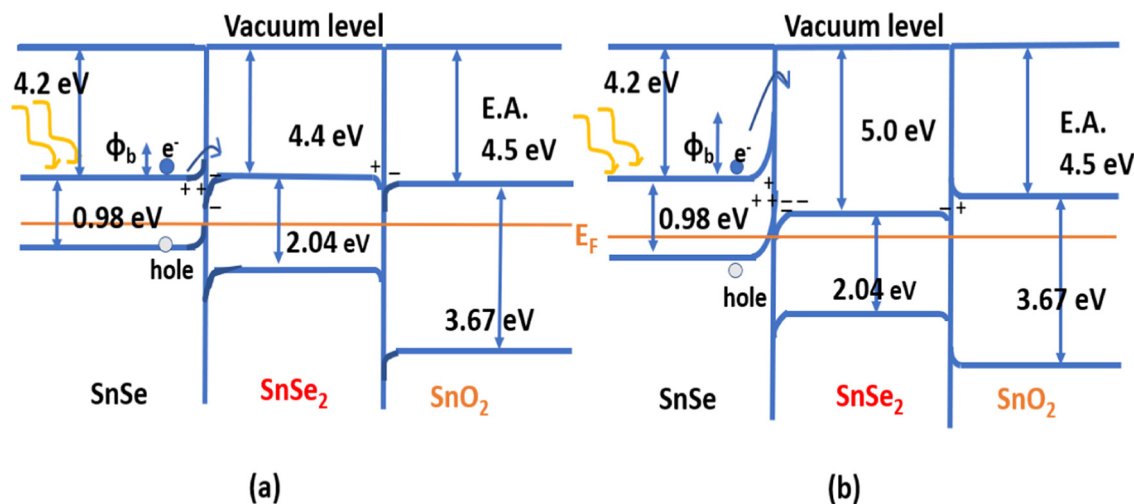


Fig. 6 Schematic diagram of the band alignment of the configuration when the E.A. of SnSe_2 is (a) 4.4 eV and (b) 5.0 eV. E.A. (5.0 eV) makes the barrier a greater height and creates a potential well in the transportation of the carriers.

mode can be tuned in the UV or IR region by selecting annealing conditions. The device annealed for 1 hour showed average behavior in the PC mode (although there is a slight variation in the parameters). The efficiency of the as-annealed SnSe indicates the hidden potential of SnSe. A more insightful study must be done to control the electron affinity of the SnSe_2 that seems sensitive toward oxidation. As confirmed by the decay time calculation, the trap/defect states in the device are still a significant hurdle in its optoelectronics applications.

Further improvement in the annealing conditions may improve the absorber and buffer layer properties, enhancing the PC and PV mode properties. Also, a simulation study showed that an efficiency of 20.27% can be obtained under certain conditions. Thus, a tin selenide solar cell structure can be obtained by open-air annealing, requiring fewer fabrication steps. Therefore, it can address the emerging demands for cheap and stable solar cells.

Data availability

Data will be made available upon request with proper justification.

Conflicts of interest

The authors declare that they have no known competing financial interests or personal relationships that could have influenced the work reported in this paper.

Acknowledgements

M. Kumar, S. Rani, and P. Vashishtha acknowledge the Council for Scientific and Industrial Research (CSIR), India, and UGC for the Senior Research Fellowship (SRF). The authors would like to thank Director CSIR-NPL for his constant support. We

also thank Professor Burgelman of Gent University, Belgium, for providing the SCAPS program.

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